

<b>Form PTO-1449</b> <b>INFORMATION DISCLOSURE CITATION</b> <b>IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>	Docket Number 245402008300	Application Number Not Yet Assigned
	Applicant Nobuaki TERAGUCHI	
	Filing Date Concurrently Herewith	Group Art Unit Not Yet Assigned
	Mailing Date February 3, 2004	

## U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate

## FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
<i>12</i>	1.	05/11/1993	JP 5-291621	Japan			Abstract

## OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
<i>12</i>	2.	Ruvimov, S. et al. (1998). "Microstructure of Ti/Al Ohmic Contacts for n-AlGaIn," <i>Appl. Phys. Lett.</i> 73(18):2582-2584.

EXAMINER:

*Nitin Parekh*

DATE CONSIDERED:

*04/20/05*

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.